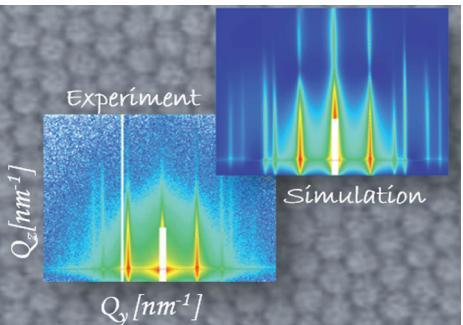
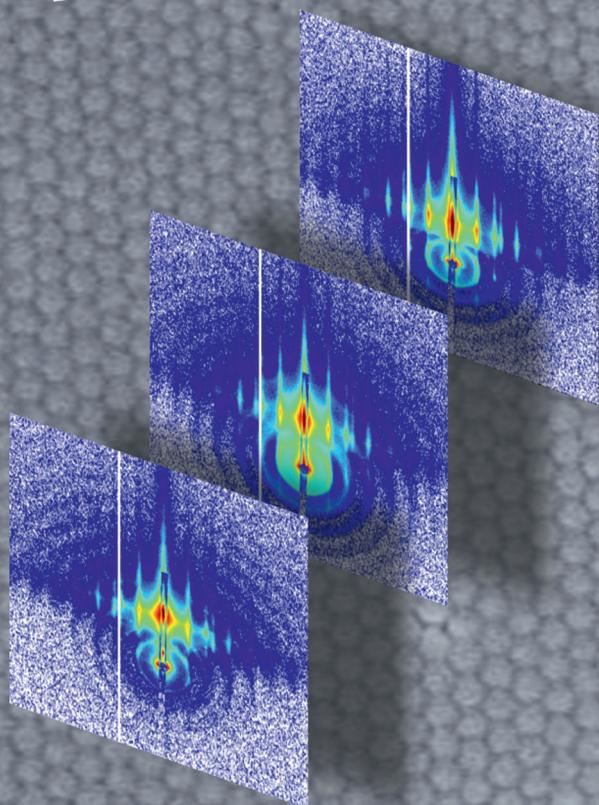
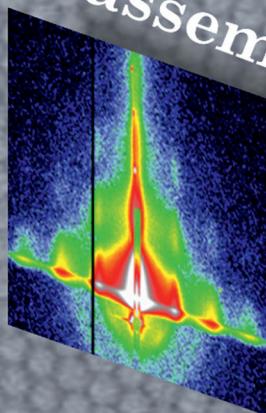


2D assembly



3D assembly



Nanoparticle assemblies: Order by self-organization and collective magnetism

Asma Qdemat

Schlüsseltechnologien / Key Technologies

Band / Volume 236

ISBN 978-3-95806-542-0

Forschungszentrum Jülich GmbH
Jülich Centre for Neutron Science (JCNS)
Quantenmaterialien und kollektive Phänomene (JCNS-2/PGI-4)

Nanoparticle assemblies: Order by self-organization and collective magnetism

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Schriften des Forschungszentrums Jülich
Reihe Schlüsseltechnologien / Key Technologies

Band / Volume 236

ISSN 1866-1807

ISBN 978-3-95806-542-0

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ISBN 978-3-95806-542-0